

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Peter KOCHERSPERGER

Appl. No.: 10/780,877

Filed: February 19, 2004

For: **Overlay Correction By Reducing
Wafer Slipping After Alignment**

Confirmation No.: 1990

Art Unit: 2822

Examiner: Duong, Khanh B.

Atty. Docket: 1857.2140000

**Submission under 37 C.F.R. §1.114 and a Preliminary Amendment under
37 C.F.R. § 1.115**

Mail Stop RCE

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Filed concurrently herewith in the captioned application is a Request for Continued Examination (RCE). Prior to examination of the RCE on the merits, please amend the application as directed herein. Applicants submit the following Amendment and Remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks and Arguments begin on page 4 of this paper.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.